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| SERIAL NUMBER | FILING or 371(c) DATE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. | | |
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| 10/549,938 | 01/03/2007 | 438 | 2891 | 1592-0169PUS1 | | |
| RULE | | | | | | |
| APPLICANTS Takashi Ozaki, Toyama, JAPAN; Kazuhiro Yuasa, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/12214 08/25/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-301982 08/26/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/30/2007 | | | | | | |
| Foreign Priority claimed | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY | SHEETS DRAWINGS | TOTAL CLAIMS | INDEPENDENT CLAIMS |
| 35 USC 119(a-d) conditions met | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | | JAPAN | 21 | 24 | 1 |
| Verified and | /CARIDAD EVERHART/ | Initials | | | | |
| Acknowledged | Examiner's Signature | | | | | |
| ADDRESS BIRCH STEWART KOLASCH & BIRCH PO BOX 747 FALLS CHURCH, VA 22040-0747 UNITED STATES | | | | | | |
| TITLE Producing method of semiconductor device and substrate processing apparatus | | | | | | |
| FILING FEE RECEIVED 1230 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees | | | |
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